



Docket No.: APW-022
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Eiji Hashimoto *et al.*

Application No.: 10/656382

Confirmation No.: 8525

Filed: September 5, 2003

Art Unit: 2121

For: CONTROL SYSTEM FOR PLANT

Examiner: S. Chang

RESPONSE

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed August 12, 2005, the response period of which is extended to December 12, 2005, by the accompanying Request for Extension of Time, Applicants submit the following Remarks to place the application in condition for allowance.